

In re application of: Dan Lillie et al.

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For:

ETCHING SOLUTION FOR FORMING AN EMBEDDED RESISTOR

Assistant Commissioner for Patents

Washington, DC 20231

U.S. Patent Documents

Examiner	Document			
Initials	Number	Name	Date	Class
RC	2,230,156	Carman	January 28, 1941	41/42
Pa	2,687,345	Murray	August 24, 1954	41/42
N	3,102,808	Weisberg et al.	September 3, 1963	75/97
A	3,607,450	Kiewit	September 21, 1971	148/1.5
1/2	3,644,155	Hogya et al.	February 22, 1972	156/20
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12	4,370,197	Abolafia et al.	January 25, 1983	156/659
12	4,588,471	Griffith et al.	May 13, 1986	156/652
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A	5,017,271	Whewell et al.	May 21, 1991	204/15
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R	6,117,250	Schemenaur et al.	September 12, 2000	148/248
n	6,150,279	Ku	November 21, 2000	438/707

Examiner: Roberts . P. Culbert

Date Considered:

2/12/2004

**Examiner:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.